

AUG 08 2005

RESPONSE UNDER ~~37 CFR~~ 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2826PATENT APPLICATION  
Doc. No.: 4591-366  
Client Ref. No.: IC12242-US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Jeong-Min CHOI and Tae-Hong HA

Serial No.: 10/750,983 Examiner: Erdem, Fazli

Filed: January 2, 2004 Group Art Unit: 2826

Confirmation No.: 5470

For: SEMICONDUCTOR DEVICE HAVING SILICIDE LAYERS AND  
METHOD OF FABRICATING THE SAMEMail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116**

This paper is responsive to the Final Office Action, Paper No. 04022005, dated 7 April 2005.

**Specification Amendments** begin on page 2 of this paper.

**A Listing of Claims** that reflects the current status of the claims begins on page 4 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.